			_			-			1 " - 4	
Form PTO-1449 LIST OF ART CITED (Use several sheets			U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1035			SERIAL NO. 09/234,233		
			BY APPLICA?	BY APPLICANT If necessary) APPLICANT Weimin 11 e		el				
SP 0 3 25.3 E				FILING DATE GROUP January 20, 1999 2818						
	akir.			U.S. PATENT DOCUMENTS						
Initial Initial	OF	Document Number	Date	(Name		Class	Sebelass	Filing Date If Appropriate		
D\	М	4.775.478	07/1988	Abernathey et al			· ·			
	AB	4,870,470	09/1989	Bass et al		<u> </u>				
	AC	5,312,768	05/1994	Gonzalez						
	AD	5,439,838	08/1995	Yang						
9	AE	6,001,747	12/1999	Annapragada						
	AF	6,518,122	02/2003	Chan		-				
	AG	6,492,688	12/2002	ng						
	AH	6,373,114	04/2002	Jeng						
DV	AJ	2001/0019868	09/2001	Genzalsz et al		<u> </u>				
	AJ									
	AK						,			
	AL			·						
				FOREIGN PATENT DOCUMEN	vTS	T				
		Document Number	Date	Country		Class	Subclass	Trens Yes	intion No	
· · ·	AM-					<u> </u>				
	AN		†							
	AO								<u> </u>	
	AP					<u> </u>				
	AQ			<u> </u>					<u> </u>	
		07	THER REFEREN	CES (including Author, Title, Dat	e, Pertinent Pages, Etc	:-)				
٥٧	AR	. Welf, S., "Silicon	Processing for t	the VLSI Era," Vol. 1, pps. 189-i	190.					
	├									
	1 , 1									
	AS									
	AS									

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Drew line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DATE CONSIDERED

12/08/03

Shuland

EXAMINER